

Electronic Acknowledgement Receipt

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|---|---|
| EFS ID: | 5258352 |
| Application Number: | 10520141 |
| International Application Number: | |
| Confirmation Number: | 9522 |
| Title of Invention: | LARGE-DIAMETER SiC WAFER AND MANUFACTURING METHOD THEREOF |
| First Named Inventor/Applicant Name: | Shigehiro Nishino |
| Customer Number: | 25944 |
| Filer: | Christopher W. Brown/Tricia Aldrich |
| Filer Authorized By: | Christopher W. Brown |
| Attorney Docket Number: | 122261 |
| Receipt Date: | 01-MAY-2009 |
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| Application Type: | U.S. National Stage under 35 USC 371 |

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| Submitted with Payment | yes |
| Payment Type | Deposit Account |
| Payment was successfully received in RAM | \$1810 |
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File Listing:

| Document Number | Document Description | File Name | File Size(Bytes)/Message Digest | Multi Part /.zip | Pages (if appl.) |
|-----------------|-----------------------------|-----------------------|---|------------------|------------------|
| 1 | Issue Fee Payment (PTO-85B) | 05-01-09-feetrans.pdf | 95440 4adc175d2c74646c631fb7554128e2c7ba1 41b75 | no | 1 |

Warnings:**Information:**

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|---|-------------------------|--------------|---|----|---|
| 2 | Fee Worksheet (PTO-875) | fee-info.pdf | 32049 8d969b84cb283e9aa6020f1f79db6e2565f1 ee05 | no | 2 |
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If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

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